



PATENT 8017-1195

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicants: Takeshi NAKATA et al.

Confirmation: 4547

Serial No.:

10/589,004

Art Unit:

2811

Filed:

August 10, 2006

Examiner Not assigned

For:

SEMICONDUCTOR PHOTO-DETECTING ELEMENT

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents

October 23, 2006

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, included with the accompanying Form PTO-1449 is a copy of the cited reference and an English language abstract thereof, thereby satisfying the requirement for a concise explanation of relevance.

This Information Disclosure Statement is being submitted within three months of the filing date of the present application; therefore, no fee is required. The Examiner is courteously requested to initial and return a copy of the Form PTO-1449 to confirm consideration of the listed document.

Respectfully submitted,

YOUNG & THOMPSON

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)				Attorney Docket No.: 8017-1195			Application No.: 10/589,004			
				Applicant: Takeshi NAKATA et al.						
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not in conformance and not considered. Include copy of this form with next communication to the applicant.

* English language abstract provided for the Examiner's convenience